

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Bernhard Kneer et al.                      Art Unit : Unknown  
Serial No. : 10/597,806                                      Examiner : Unknown  
Filed : August 8, 2006                                      Conf. No. : 6572  
Title : PROJECTION OBJECTIVE FOR A MICROLITHOGRAPHIC PROJECTION  
EXPOSURE APPARATUS

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicants request consideration of the references listed on the attached PTO-1449 form. Under 37 C.F.R. § 1.98 (a)(2)(ii), only copies of foreign patent documents and/or non-patent literature are enclosed. Copies of any listed U.S. patents or U.S. patent application publications can be provided upon request. A copy of an International Preliminary Report on Patentability from a counterpart application is also enclosed.

This statement is being filed within three months of the filing date of the application. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: September 22, 2006

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Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 18239-023US1	Application No. 10/597,806
<b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary)		Applicant Bernhard Kneer et al.	
		Filing Date August 8, 2006	Group Art Unit
(37 CFR §1.98(b))			

**U.S. Patent Documents**

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	5,446,591	08/29/1995	Medlock			
	AB	5,627,674	05/06/1997	Robb			
	AC	6,169,627	01/02/2001	Schuster			
	AD	6,496,306	12/17/2002	Shafer et al.			
	AE	2002/0196533	12/26/2002	Shafer et al.			
	AF	2003/0224528	12/04/2003	Chiou et al.			
	AG	2004/0105170	06/03/2004	Krahmer et al.			

**Foreign Patent Documents or Published Foreign Patent Applications**

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AH	JP 2000-58436	02/25/2000	Japan			X	
	AI	WO 01/50171	07/12/2001	WIPO			English abstract	
	AJ	WO 02/093209	11/21/2002	WIPO			English abstract	

**Other Documents (include Author, Title, Date, and Place of Publication)**

Examiner Initial	Desig. ID	Document
	AK	Saurci et al., "Design of an autofocus lens for VGA 1/4-inch CCD and CMOS sensors," <i>SPIE International Symposium: Optical Systems Design</i> , St. Etienne, France, 1 page (2003)

Examiner Signature /Meslin Asfaw/	Date Considered 10/24/2008
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	